



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of

Minoru KATAYAMA et al.

Group Art Unit: 2856

Application No.: 09/690,590

Examiner: M. Cygan

Filed: October 18, 2000

Docket No.: 107612

For: SURFACE TEXTURE MEASURING MACHINE, LEVELING DEVICE FOR
SURFACE TEXTURE MEASURING MACHINE AND ORIENTATION-ADJUSTING
METHOD OF WORKPIECE OF SURFACE TEXTURE MEASURING MACHINE

REQUEST FOR APPROVAL OF DRAWING CORRECTIONS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed corrections to
Figures 17 and 18, marked in red on the attached copy of such drawing figures.

Upon approval by the Examiner, and upon allowance of this application, the formal
drawings will be corrected.

Respectfully submitted,

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JAO:RJK/sld

Date: July 9, 2002

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